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TRANSMITTAL FORM		Application Number	10/072,357	
		Filing Date	2/6/2002	
		First Named Inventor	Michael D. Kilgore	
		Group Art Unit	2822	
atto be used for all correspondence after initial filing)		Examiner Name	Maria F. Guerrero	
Total Number Of Pages In Th	nis Submission 7	Attorney Docket No.	NVS014 U	is J
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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. No.

10/072,357

Confirmation No. 4288

First Inventor

Michael D. Kilgore

Filing Date

2/6/2002

Tech. Center/

2822

Examiner

Maria F. Guerrero

Art Unit

Title:

High Density Plasma Process For Optimum Film Quality And

**Electrical Results** 

Docket No.:

NVS014 US

Customer No.:

34036

Santa Clara, California June 23, 2004

Mail Stop AF COMMISSIONER FOR PATENTS P.O. Box 1450 Alexandria, VA 22313-1450

## AMENDMENT AFTER FINAL ACTION AND SUMMARY OF TELEPHONE INTERVIEW

Dear Sir:

In response to Office Action dated March 29, 2004, please amend the aboveidentified application as follows.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 5 of this paper.